



IN THE U.S. PATENT AND TRADEMARK OFFICE  
May 14, 2008

Applicants : Yoshio KAJIYA et al  
Title : METHOD OF PRODUCING CATHODE MATERIAL FOR  
LITHIUM SECONDARY CELL  
Serial No. : 10/521 370 Group: 1795  
Confirmation No.: 2268  
Filed : January 12, 2005 Examiner: Echelmeyer  
International Application No.: PCT/JP2003/002027  
International Filing Date : February 25, 2003  
Atty. Docket No.: 4402.P0666US  
Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**PETITION FOR TIME EXTENSION, AND CERTIFICATE OF MAILING**

Sir:

A Notice of Appeal is enclosed.


Pursuant to 37 CFR 1.136(a), please extend the shortened period for response by three months. The extension fee is:

[X] \$1,050.00 (37 CFR 1.17)

A check for \$1,560.00 is enclosed to cover fees.

If this Petition is not timely received, please extend the shortened period an additional month. Please credit any overpayment, or charge any additional fee required by this Petition, to Deposit Account No. 06-1382. A duplicate of this Petition is enclosed.

Respectfully submitted,

IN DUPLICATE  
TFC/smd  
Terryence F. Chapman

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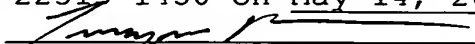
Notice of Appeal dated May 14, 2008

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**CERTIFICATE OF MAILING**

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on May 14, 2008.

  
Terryence F. Chapman